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APPLICATION NO. FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/840,178	04/24/2001	Toshifumi Nagaiwa	206342US2	2640	
22850	7590 10/08/2002				
OBLON SPIVAK MCCLELLAND MAIER & NEUSTADT PC FOURTH FLOOR 1755 JEFFERSON DAVIS HIGHWAY			EXAMINER		
			KACKAR, RAM N		
ARLINGTON	N, VA 22202		ART UNIT	PAPER NUMBER	
			1763	8	
			DATE MAILED: 10/08/2002		

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary		Application No		Applicant(s)	114				
		09/840,178		NAGAIWA ET AL	-				
		Examiner		Art Unit					
		Ram N Kackar		1763					
The MAILING Period for Reply	DATE of this communication ap	ppears on the cove	er sheet with the co	orrespondence ac	ldress				
THE MAILING DATE  - Extensions of time may be after SIX (6) MONTHS from  - If the period for reply specil  - If NO period for reply is specil  - Failure to reply within the significant of the specific	ATUTORY PERIOD FOR REPLE OF THIS COMMUNICATION. available under the provisions of 37 CFR 1. In the mailing date of this communication. fied above is less than thirty (30) days, a rejectified above, the maximum statutory period et or extended period for reply will, by statul of the provision of the mailing ment. See 37 CFR 1.704(b).	.136(a). In no event, how ply within the statutory mi d will apply and will expire te, cause the application	vever, may a reply be time inimum of thirty (30) days s SIX (6) MONTHS from to to become ABANDONED	ely filed will be considered time ne mailing date of this o (35 U.S.C. § 133).					
1) Responsive to	communication(s) filed on 20	September 2002							
2a) This action is	FINAL. 2b) T	his action is non-f	final.						
Disposition of Claims	·								
4)⊠ Claim(s) <u>1-3,5</u>	-7,9,12,14-17 and 19-24 is/are	pending in the ap	oplication.						
4a) Of the abov	re claim(s) is/are withdra	awn from conside	ration.						
5) Claim(s)	_ is/are allowed.								
6) Claim(s)	_ is/are rejected.								
7)⊠ Claim(s) <u>12 an</u>	<u>d 21</u> is/are objected to.								
8) Claim(s)	are subject to restriction and/	or election require	ement.						
Application Papers									
	n is objected to by the Examin								
	filed on is/are: a)□ acce								
	not request that any objection to the								
	rawing correction filed on			ed by the Examir	er.				
	rrected drawings are required in re		ction.						
<i>,</i> —	laration is objected to by the E	xaminer.							
Priority under 35 U.S.C.									
•	ent is made of a claim for foreig	n priority under 3	5 U.S.C. § 119(a)	-(d) or (f).					
a)⊠ All b)∐ So	me * c) None of:								
	copies of the priority documen								
2.☐ Certified	copies of the priority documen	its have been rece	eived in Applicatio	n No					
appli	of the certified copies of the prio cation from the International Bo d detailed Office action for a lis	ureau (PCT Rule	17.2(a)).		Stage				
<u></u>	t is made of a claim for domes		•		l application)				
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· —	ation of the foreign language pr nt is made of a claim for domes								
Attachment(s)									
	ed (PTO-892) Patent Drawing Review (PTO-948) tatement(s) (PTO-1449) Paper No(s)	4) 5) 6)	Interview Summary Notice of Informal P						

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#### **DETAILED ACTION**

## Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless —
(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

2. Claims1, 5-6, 14, 17, 20 and 22-24 are rejected under 35 U.S.C. 102(b) as being anticipated by Nozawa Toshihisa et al (JP 07310187). Nozawa et al discloses a process chamber for semiconductor process, having means for process gas and vacuum, means for exciting plasma (Fig 1), a work table device comprising an electrostatic chuck having passage for cooling (Fig 1 and paragraph 7), a main surface (Fig 1 and abstract) for substrate and a sub-surface for a focus ring (Abstract), cooling mechanism for both main surface and sub surface (Paragraph 4-11) and a heat transfer medium for focus ring (Paragraph 10), a bolt which is equivalent to a clamp configured to press the focus ring against the sub surface (Fig 2-23), where in cooling means maintains the substrate and the focus ring at the same temperature (Paragraph 10).

## Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims 2-3 and 15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Nozawa Toshihisa et al (JP 07310187) in view of Faretra (US Patent Nr 4282924). Nozawa et al

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do not explicitly disclose that the heat transfer medium for focus ring is a solid material. Faretra discloses use of thermally conductive silicon rubber as a heat transfer medium (Col 3 line 35-36, line 63-68 and Col 4 line 1-2). Therefore it would have been obvious to one having ordinary skill in the art at the time invention was made to use a good thermal transfer medium like silicon rubber to have good conductivity to the main surface.

- Claims 7 and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Nozawa Toshihisa et al (JP 07310187) in view of Lu et al (US Patent Nr 5904778). Nozawa Toshihisa et al disclose conductive film on the protective plate (Paragraph 5 line 19 from top) but do not expressly disclose that the focus ring consists of a conductive material. They however disclose that the heat transfer medium is conductive (Paragraph 10). Lu et al discloses that focus ring can be made of heat conductive material like silicon carbide (Col 10 table 4 first entry). Therefore it would have been obvious to one having ordinary skill in the art the time invention was made to use thermally conductive silicon carbide for focus ring for its efficient cooling.
- Claims 9 and 19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Nozawa Toshihisa et al (JP 07310187) in view of Shahvandi et al (US Patent Nr 5405491). Nozawa et al disclose the need to press focus ring on to subsurface but do not disclose a clamp frame. Shahvandi et al disclose a clamp mechanism for clamping flat horizontal objects from above and an extending portion extending downward and fixed to a fixing member (Fig 3-42), made substantially of ceramic (Fig 3 40 and Fig 4-46). Therefore it would have been obvious to one having ordinary skill in the art the time invention was made to use a clamp for pressing the focus ring on to sub-surface for good cooling.

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## Allowable Subject Matter

Claim12 and 21 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

# Response to Amendment

Applicants arguments filed on 9/20/2002 have been considered but not found to be persuasive. Applicant's arguments regarding Noda have become moot as a different reference is used in view of applicants amendments.

#### Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ram N Kackar whose telephone number is 703 305 3996. The examiner can normally be reached on M-F 8:00 A.M to 5:P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on 703 308 1633. The fax phone numbers for the organization where this application or proceeding is assigned are 703 872 9310 for regular communications and 703 872 9311 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703 308 0661.

RK October 3, 2002.

SUPPLIES TO THE COMMER